

## COPY OF PAPERS ORIGINALLY FILED

**PATENT** Attorney Reference No. 6047-55230

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Gilton et al.

Art Unit: 2814

Application No. 09/579,345

Filed: May 25, 2000

CERTIFICATE OF MAILING

SEMICONDUCTOR FABRICATION METHODS For:

I hereby certify that this paper and the documents referred to as being attached or enclosed herewith are being deposited with the United States Postal Service on January 16, 2002, as First Class Mail in an envelope addressed to: BOX NON-FEE AMENDMENT, COMMISSIONER FOR

AND APPARATUS

S, WASHINGTON, D.C. 20231.

Examiner: S. Rao

Jeffrey B. Haendler, Esq. Attorney for Applicant

Date: January 16, 2002

#### TRANSMITTAL LETTER

**BOX NON-FEE AMENDMENT COMMISSIONER FOR PATENTS** Washington, D.C. 20231

Enclosed is a Response to Office Action for the above application. The fee has been calculated as shown below.

#### **CLAIMS AS AMENDED**

For	No. after amendment	No. paid for previously		Present Extra	Rate	Fee	
Total Claims	38	- 38*	=	0	\$18.00	\$	0.00
Indep. Claims	12	12**	=	0	\$80.00	\$	0.00
TOTAL ADDITIONAL FEE FOR THIS RESPONSE						\$	0.00

<sup>\*</sup> greater of twenty or number for which fee has been paid.

 $\boxtimes$ No additional fee is required.

 $\boxtimes$ 

Please charge any additional fees that may be required in connection with filing this amendment and any extension of time, or credit any overpayment, to Deposit Account No. 02-4550. A copy of this sheet is enclosed.

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<sup>\*\*</sup> greater of three or number for which fee has been paid.

Please return the enclosed postcard to confirm that the items listed above have been received.

Respectfully submitted,

KLARQUIST SPARKMAN CAMPBELL LEIGH & WHINSTON, LLP

By

Jeffrey B. Haendler, Esq. Registration No. 43,652

One World Trade Center, Suite 1600 121 S.W. Salmon Street Portland, Oregon 97204 Telephone: (503) 226-7391

cc: Docketing

Facsimile: (503) 228-9446

JBH:jjv 01/16/02 6047-55230



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METHODS AND APPARATUS

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Jeffrey B. Haendler, Esq. Attorney for Applicants

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## RESPONSE TO OFFICE ACTION AND SUMMARY OF TELEPHONE CONFERENCE

A telephone conference was conducted on January 8, 2002 between applicants' attorney and Examiner Rao. During the telephone conference, Examiner Rao indicated that applicants' written Request For Interview, dated November 1, 2001, was fully responsive to the Office action of October 10, 2001, and no further submission was necessary. Examiner Rao also indicated that another Office action will issue in due course for the present application

Respectfully submitted,

KLARQUIST SPARKMAN CAMPBELL LEIGH & WHINSTON, LLP

By

Jeffrey B. Haendler Registration No. 43,652

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